



PATENT APPLICATION  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79289

Masayuki TAKASHIMA, et al.

Appln. No.: 10/750,971

Group Art Unit: 1751

Confirmation No.: 1869

Examiner: Brian P. MRUK

Filed: January 5, 2004

For: CLEANING SOLUTION FOR SEMICONDUCTOR SUBSTRATE

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

On December 28, 2006, pursuant to 37 C.F.R. § 1.136, Applicant petitioned for an extension of time of one-month, extending the time for responding to the Office Action dated August 28, 2006 to December 28, 2006.

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of an additional two months, extending the time for responding to the outstanding Office Action from December 28, 2006 to February 28, 2007.

A check for the statutory fee of \$900.00 is attached (\$1020.00 - \$120.00). The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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CUSTOMER NUMBER

Date: February 13, 2007